From: 8064986673 To: 00215712738300 Page: 5/13 Date: 2006/2/9 下午 02:32:52

Appl. No. 10/711,140
Amdt. dated February 09, 2006
Reply to Office action of November 29, 2005

## Amendments to the Claims:

- 1. (Currently amended) A junction varactor comprising:
  - a gate finger lying across an ion well of a semiconductor substrate;
- a gate dielectric situated between said gate finger and said ion well;
  - a first ion diffusion region with first conductivity type located in said ion well at one side of said gate finger, said first ion diffusion region serving as an anode of said junction varactor; and
  - a first lightly doped drain (LDD) having said first conductivity type in said ion well, and wherein said first LDD merges with said first ion diffusion region and extends laterally to said gate finger; and
  - a second ion diffusion region with a second conductivity type located in said ion well at the other side of said gate finger, said second ion diffusion region serving as a cathode of said junction varactor.

15

10

2. (Original) The junction varactor according to claim 1 wherein the ion well has said second conductivity type.

 $C_{\alpha} \times 1$ 

- 3. (Original) The junction varactor according to claim 1 wherein said ion well is electrically isolated by shallow trench isolation (STI).
  - 4. (Canceled)
- 5. (Original) The junction varactor according to claim 1 wherein said junction varactor further comprises a second lightly doped drain (LDD) having said second conductivity type in said ion well, and wherein said second LDD merges with said second ion diffusion region and extends laterally to said gate.

From: 8064986673 To: 00215712738300 Page: 6/13 Date: 2006/2/9 下午 02:32:52

要<mark>在我们的</mark>是一个不是一个,我们的一个,我们的一个,我们的一个,我们的一个,我们的一个,我们的一个,我们的一个,我们的一个,我们的一个,我们的一个,我们的一个,我们

Appl. No. 10/711,140 Amdt. dated February 09, 2006 Reply to Office action of November 29, 2005

- 6. (Original) The junction varactor according to claim 1 wherein said junction varactor further comprises a spacer located on sidewalls of said gate.
- 7. (Original) The junction varactor according to claim 1 wherein said junction varactor further comprises a salicide layer formed on said gate and on said first and second ion diffusion regions.
- 8. (Original) The junction varactor according to claim 1 wherein, in operation, said gate of said junction varactor is biased to a gate voltage V<sub>G</sub> that is not equal to 0 volt.
  - 9. (Currently amended) The junction varactor according to claim 1 wherein said gate <u>finger</u> is a metal gate.
- 15 10. (Currently amended) The junction varactor according to claim 1 wherein said gate finger is a polysilicon gate.
  - 11. (Original) The junction varactor according to claim 1 wherein said first conductivity type is N type and said second conductivity type is P type.
- 20

25

- 12. (Currently amended) A junction varactor comprising:
  - an N well formed in a semiconductor substrate;
  - a first gate finger lying across said N well;
  - a first gate dielectric interposed between said first gate finger and said N well;
- a second gate finger lying across said N well at one-said side of said first gate finger;
  - a second gate dielectric interposed between said second gate finger and said N well;
  - a P<sup>+</sup> ion diffusion region located in said N well between said first and second gate fingers, said P<sup>+</sup> ion diffusion region serving as an anode of said junction varactor;

From: 8064986673 To: 00215712738300 Page: 7/13 Date: 2006/2/9 下午 02:32:53

Appl. No. 10/711,140 Amdt. dated February 09, 2006 Reply to Office action of November 29, 2005

5

## a P type lightly doped drain (PLDD) merging with said P<sup>+</sup> ion diffusion region and extending to said first gate finger and said second gate finger;

a first N<sup>+</sup> ion diffusion region located in said N well at one-said side of said first gate that is opposite to said P<sup>+</sup> ion diffusion region; and

- a second N<sup>+</sup> ion diffusion region located in said N well at one-said side of said second gate that is opposite to said P<sup>+</sup> ion diffusion region, wherein said first N<sup>+</sup> ion diffusion region and said second N<sup>+</sup> ion diffusion region are electrically coupled together and serve as a cathode of said junction varactor.
- 13. (Original) The junction varactor according to claim 12 wherein, in operation, said first and second gate fingers of said junction varactor are biased to a gate voltage Vo that is not equal to 0 volt.
- 14. (Original) The junction varactor according to claim 13 wherein said gate voltage  $V_G$  is  $V_{CC}$ .
  - 15. (Withdrawn) A junction varactor comprising:
    - a P well formed in a semiconductor substrate;
    - a first gate finger lying across said P well;
- a first gate dielectric interposed between said first gate finger and said P well
  - a second gate finger lying across said P well at one said of said first gate finger;
  - a second gate dielectric between said second gate finger and said P well;
  - an N<sup>+</sup> ion diffusion region located in said P well between said first and second gate fingers, said N<sup>+</sup> ion diffusion region serving as an anode of said junction varactor;
- a first P<sup>+</sup> ion diffusion region located in said P well at one said of said first gate that is opposite to said N<sup>+</sup> ion diffusion region; and
  - a second P<sup>+</sup> ion diffusion region located in said P well at one said of said second gate that is opposite to said N<sup>+</sup> ion diffusion region, wherein said first P<sup>+</sup> ion diffusion region

From: 8064986673 To: 00215712738300 Page: 8/13 Date: 2006/2/9 下午 02:32:53

TOTAL PROPERTY AND A CONTROL OF THE PROPERTY O

Appl. No. 10/711,140 Amdt. dated February 09, 2006 Reply to Office action of November 29, 2005

and said second P<sup>+</sup> ion diffusion region are electrically coupled together and serve as a cathode of said junction varactor.

- 16. (Withdrawn) The junction varactor according to claim 15 wherein, in operation, said
   5 first and second gate fingers of said junction varactor are biased to a gate voltage V<sub>G</sub> that is not equal to 0 volt.
  - 17. (Withdrawn) The junction varactor according to claim 16 wherein said gate voltage  $V_G$  is  $V_{SS}$ .

10